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Sheet 1 of 1 Attorney Docket Number 31775-226082

Complete if Known

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| Application Number | 10/568,288-Conf. #3490 |
| Filing Date | February 6, 2007 |
| First Named Inventor | Juergen Hausselt |
| Art Unit | 1724 |
| Examiner Name | J. Berman |

Sheet 1 of 1 Attorney Docket Number 31775-226082

U.S. PATENT DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Document Number Number-Kind Code ² (if known) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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FOREIGN PATENT DOCUMENTS

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| | CA | Heavens, S.N., Electrophoretic Deposition as a Processing Route for Ceramics in Binner, J. (Ed.), Advanced Ceramic Processing and Technology, Vol. 1, Noyes Publ., Park Ridge, N.J. U.S., 1990 | <input type="checkbox"/> |
| | CB | Both, H. von; Hausselt, J.: 1 st Intern. Conf. on Electrophoretic Deposition, Banff, Canada, 2002 | <input type="checkbox"/> |
| | CC | Nitzsche, R. & Simon, F.: TECHNISCHES MESSEN [Technical Measuring] Volume 64, pages 106-113, 1997 | <input type="checkbox"/> |
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|--------------------|-----------------|
| Examiner Signature | Date Considered |
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